

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re patent application of

Hidekazu Kawashima, et al.

Serial No.: Not Yet Assigned                          Group Art Unit: Not Yet Assigned  
Filing Date: Concurrently Herewith                Examiner: Unknown  
For: METHOD AND DEVICE FOR PRODUCING LAYOUT PATTERNS OF A  
SEMICONDUCTOR DEVICE HAVING AN EVEN WAFER SURFACE

Honorable Commissioner of Patents  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following document listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. A copy of the listed document is provided herewith for the convenience of the Examiner. In compliance with the concise explanation requirement under 37 CFR §1.98(a)(3), the relevance of this document is discussed on page 2 of the subject application. Further, an English-language Abstract is attached to the reference.

This citation does not constitute an admission that the reference is relevant or material to the claims. It is only cited as constituting related art of which the applicant is aware.

It is respectfully requested that the listed reference be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,



Sean M. McGinn, Esq.  
Registration No. 34,386

Date: 11/13/04

McGinn & Gibb, PLLC  
Intellectual Property Law  
8321 Old Courthouse Road, Suite 200  
Vienna, VA 22182-3817  
(703) 761-4100  
Customer No. 21254

